PATENT

Docket No.: 52352-785

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

George Jonathan KLUTH, et al.

Serial No.: 10/071,207

Group Art Unit: 2811

Filed: February 11, 2002

Examiner:

For:

METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH

SUPERSATURATED SOURCE/DRAIN EXTENSIONS AND METAL SILICIDE

CONTACTS

TRANSMITTAL OF FORMAL DRAWINGS

Commissioner for Patents Washington, DC 20231

Sir:

At the time the above application was filed, informal drawings were presented with the application.

The formal drawings are submitted herewith.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

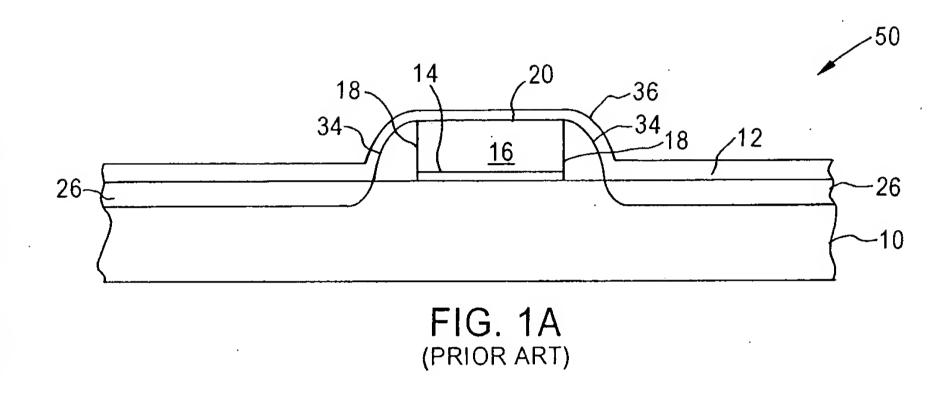
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Date: June 7, 2002



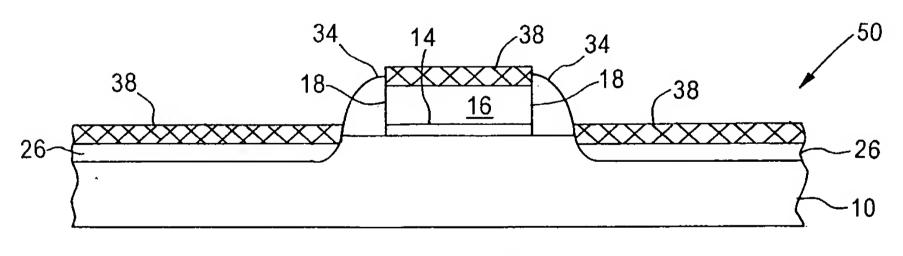


FIG. 1B (PRIOR ART)

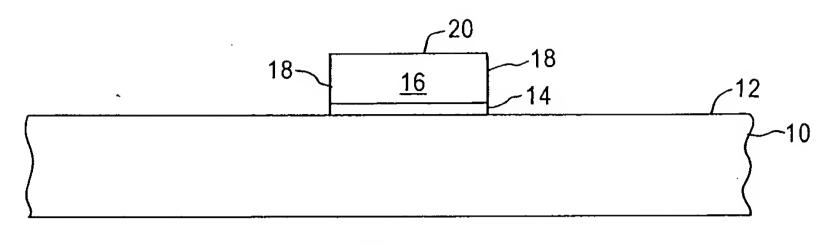
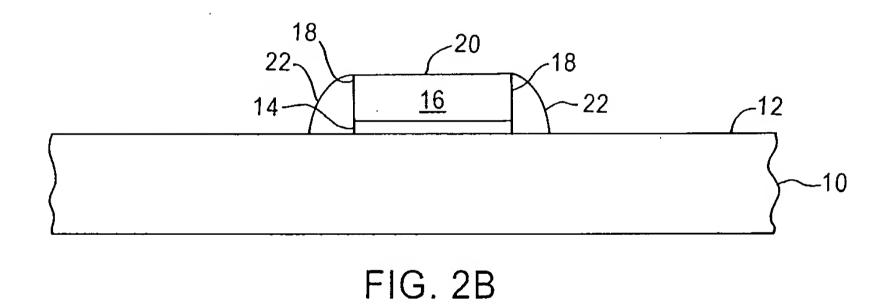


FIG. 2A



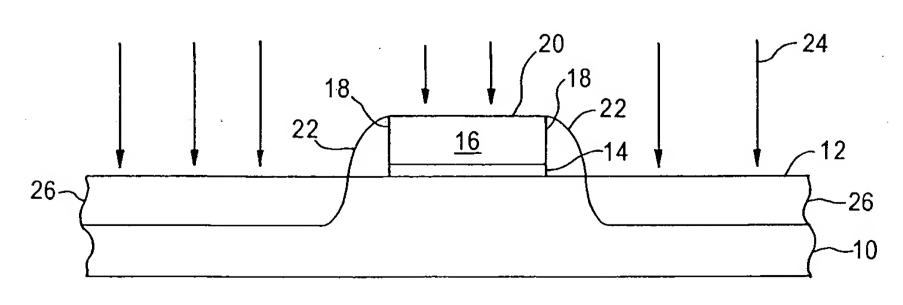
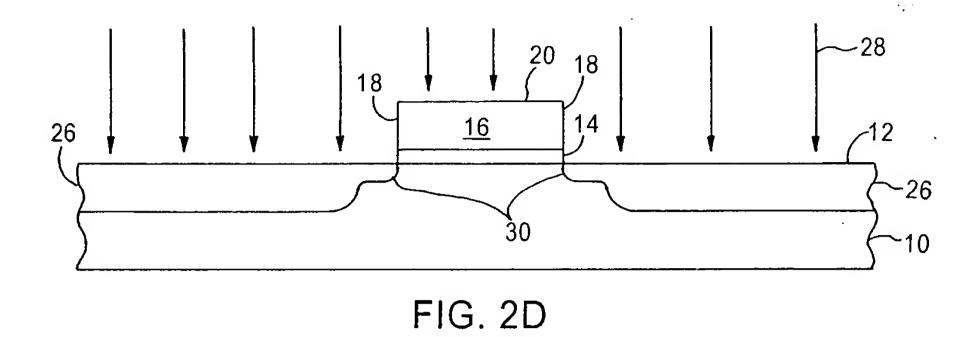
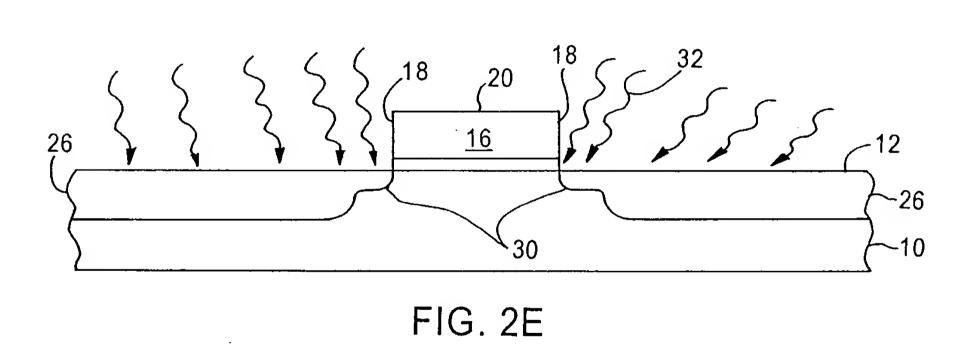


FIG. 2C





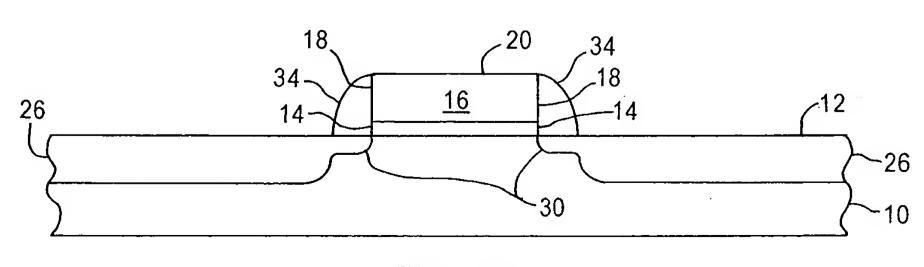
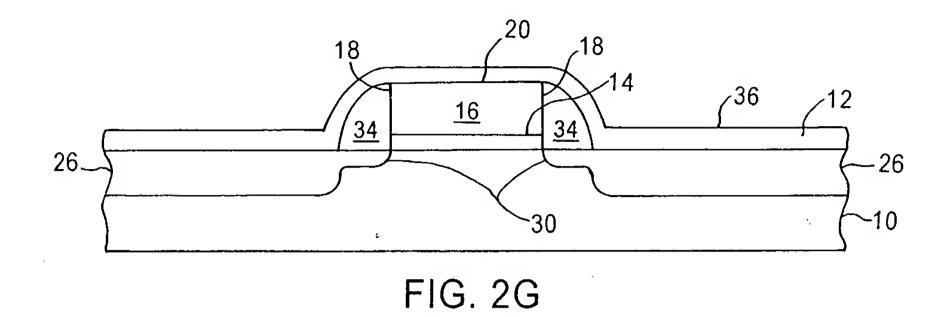
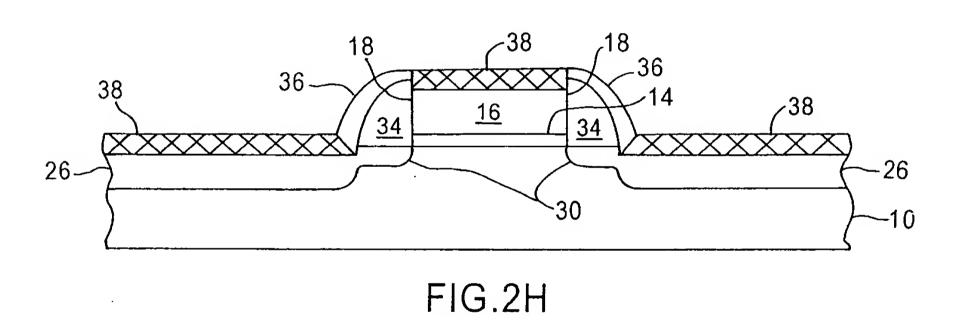


FIG. 2F





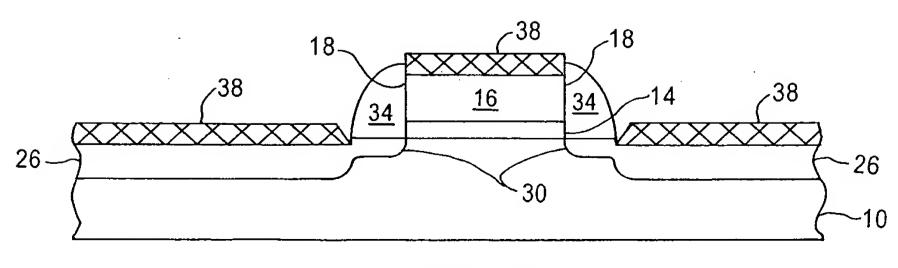
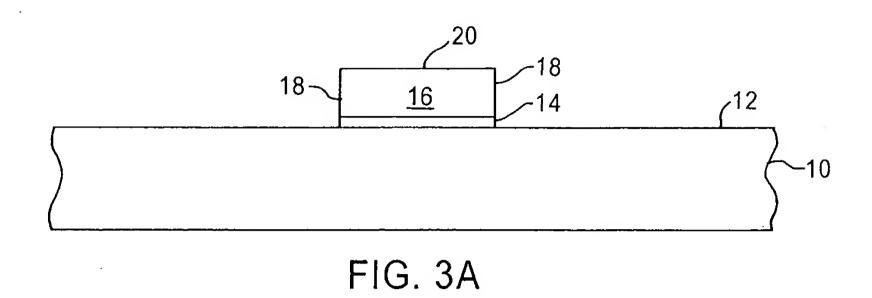
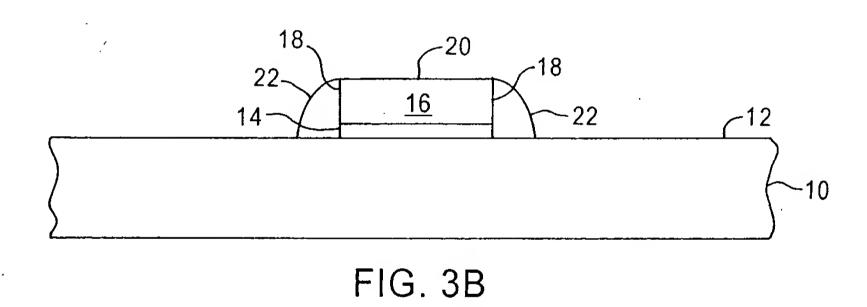


FIG. 2I





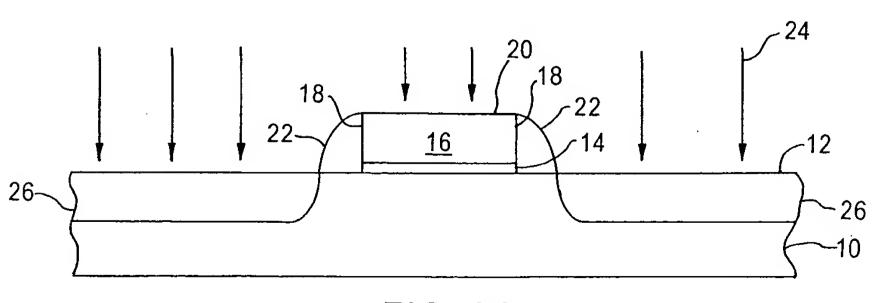
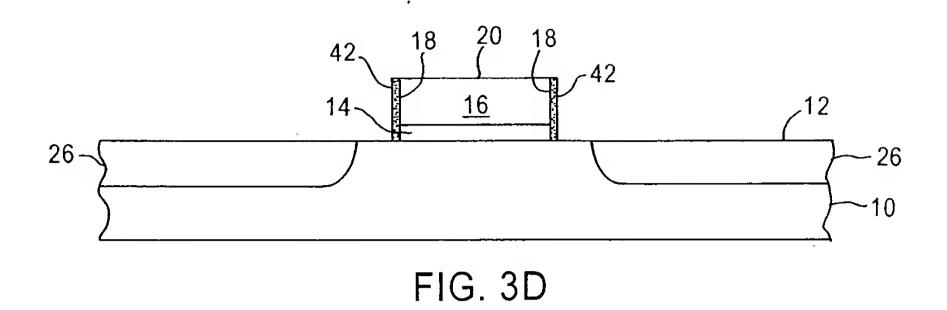
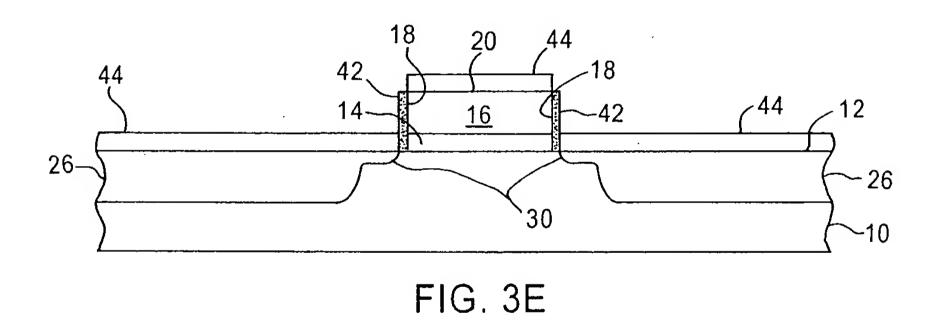


FIG. 3C





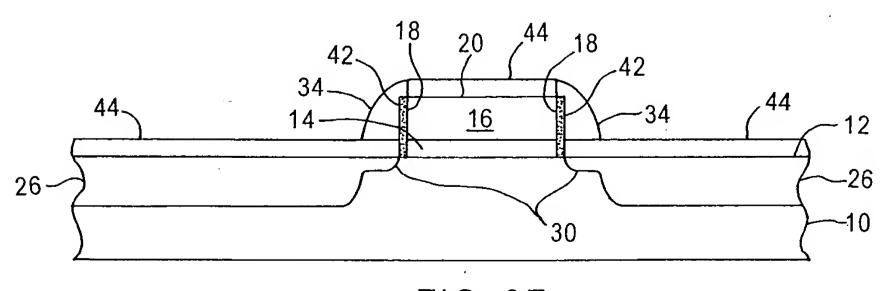


FIG. 3F

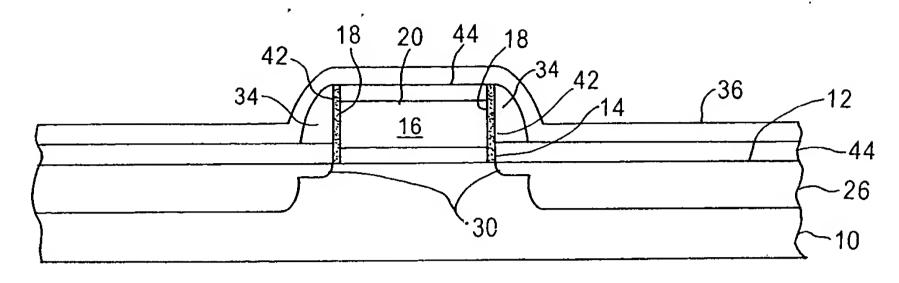


FIG. 3G

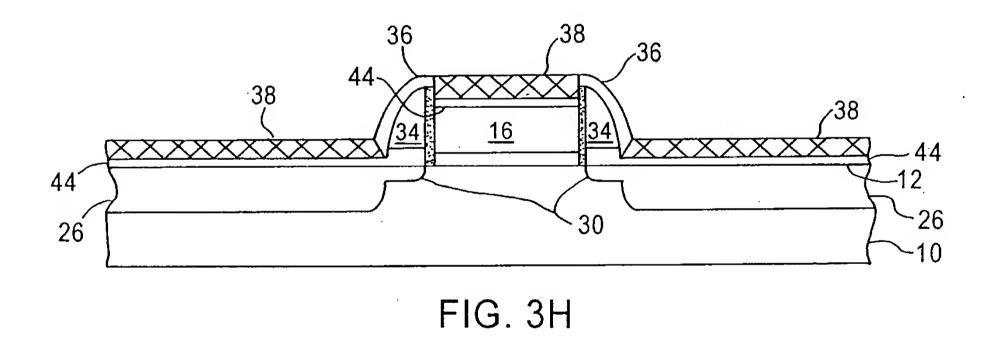


FIG. 3I

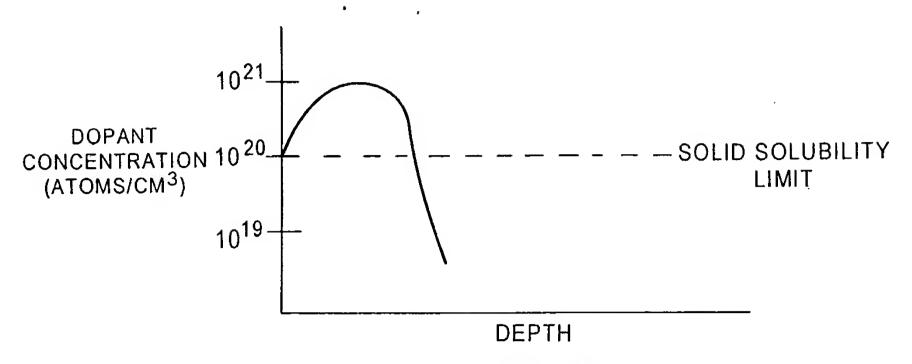


FIG. 4

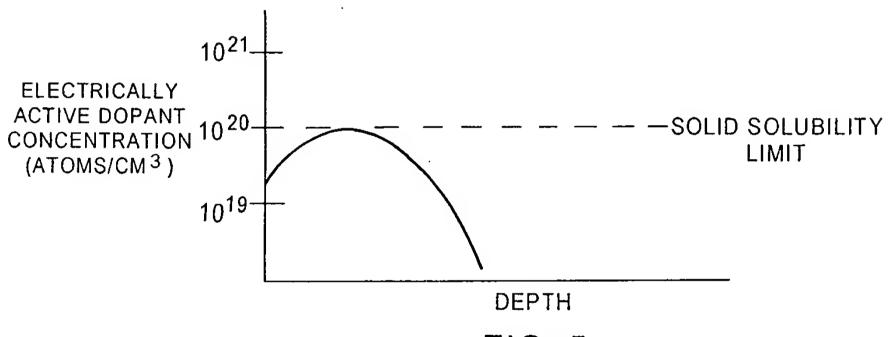


FIG. 5

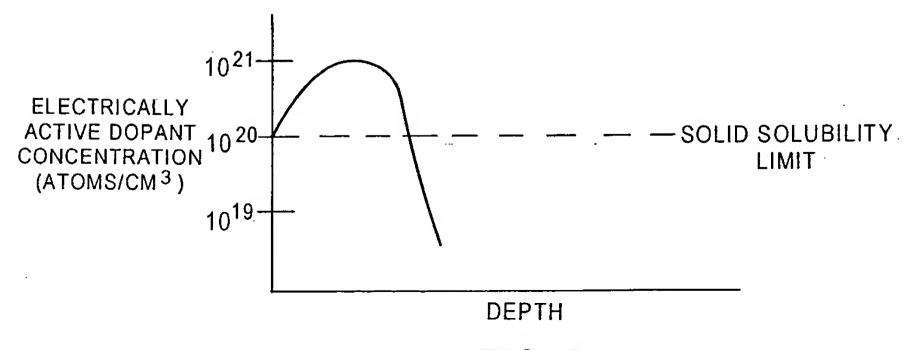


FIG. 6